

JC879 U.S. PTO
10/047818
01/15/02

PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM 10047818	FILING DATE 01/15/2002	CLASS 134	SUBCLASS 1746	GAU 1746	EXAMINER Rogers Moore
**APPLICANTS: Nishimura Joichi; Ohtani Masami; Hashinoki Kenji; Shiga Masayoshi; Hashimoto Koji; 156 345,32 1763					
**CONTINUING DATA VERIFIED:					
** FOREIGN APPLICATIONS VERIFIED: JAPAN P2001-010647 01/18/2001 JAPAN P2001-217882 07/18/2001					
PG-PUB DO NOT PUBLISH <input type="checkbox"/>		RESCIND <input type="checkbox"/>			
Foreign priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no		35 USC 119 conditions met <input type="checkbox"/> yes <input type="checkbox"/> no		ATTORNEY DOCKET NO P/1250-217	
Verified and Acknowledged Examiners's initials TITLE : Substrate processing apparatus					

U.S. DEPT. OF COMM./PAT. & TM.-PTO-436L (Rev. 12-94)

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NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Total Claims	Print Claim for O.G.
ISSUE FEE		DRAWING	
Amount Due	Date Paid	Sheets Drwg.	Figs. Drwg.
		Print Fig.	
		Application Examiner	
<input type="checkbox"/> TERMINAL DISCLAIMER		PREPARED FOR ISSUE	
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